

## IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

CHEN, Shun-An et al. Conf.: 1826

Appl. No.:

09/930,971

Group:

2863

Filed:

August 17, 2001 Examiner: Xiuqin Sun

For:

A SYSTEM FOR DYNAMICALLY MONITORING THE

STABILITY OF SEMICONDUCTOR MANUFACTURING EQUIPMENT

## REPLY UNDER 37 C.F.R. § 1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 December 29, 2004

Sir:

Responsive to the September 22, 2004 Office Action, the due date for response having been extended one (1) month, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes:

Amended Claim Set; and

Remarks.

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